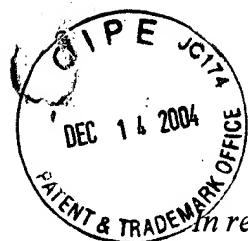


RESPONSE UNDER 37 C.F.R. §1.116
~~EXPEDITE PROCEDURE~~
GROUP ART UNIT 1753

**EXPEDITED PROCEDURE
RESPONSE AFTER FINAL**

IFW
AF



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Jong-Hwan CHA, *et al.*

Serial No.: 09/781,987

Confirmation No.: 9563

Filed: February 14, 2001

Docket No.: 6192.0094.BA

Corres. and Mail

Group Art Unit: 1753 **BOX AF**

Examiner: McDONALD, Rodney Glenn

**For: APPARATUS FOR MANUFACTURING A THIN FILM TRANSISTOR ARRAY
PANEL FOR A LIQUID CRYSTAL DISPLAY**

Mail Stop: AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REPLY AND AMENDMENT UNDER 37 C.F.R. § 1.116

Sir:

In response to the Final Office Action mailed September 17, 2004 (Paper No. 20040914) ("Office Action"), Applicants respectfully request reconsideration of the application in view of the following Amendments and Remarks.

Applicants believe that no extensions of time are required at this time. If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned for under 37 C.F.R. §1.136(a). Applicants believe that no further fees for net addition of claims are required at this time. Any fees required for further extensions of time and any fees for the net addition of claims are hereby authorized to be charged to our Deposit Account No. 23-1951.